



<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Scket No. <b>52433/797</b>	Application No. <b>10/535,346</b>	
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	Filing Date <b>October 3, 2005</b>	Confirmation No. <b>7148</b>	Art Unit <b>1793</b>

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*
/MLS/	6,171,415	January 9, 2001	Statnikov			

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
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/MLS/	1944370	06/23/1995	JP			Abstract corresponding to JP 1-110707	
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/MLS/	International Search Report dated 24 February 2004 issued in corresponding PCT Application No. PCT/JP03/14595.
/MLS/	Kazuya YAMADA et al. "Cho Onpa Shot Peening ni yoru Zairyo Hyomenso no Nano-Kesshoka" The Japan Institute of Metals Koen Gaiyo, 2 November 2002, Vol. 131, page 265 [with English Translation]

EXAMINER	/Mark L. Shevin/	DATE CONSIDERED	08/10/2010
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